



**ELECTRONIC COPY**

LG762573664  
Report verification at igi.org



January 24, 2026

IGI Report Number **LG762573664**

Description **LABORATORY GROWN DIAMOND**

Shape and Cutting Style **ROUND BRILLIANT**

Measurements **7.90 - 7.94 X 4.81 MM**

**GRADING RESULTS**

Carat Weight **1.84 CARAT**

Color Grade **E**

Clarity Grade **VS 1**

Cut Grade **IDEAL**

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**ADDITIONAL GRADING INFORMATION**

Polish **EXCELLENT**

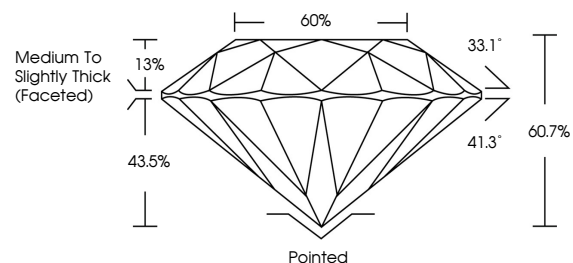
Symmetry **EXCELLENT**

Fluorescence **NONE**

Inscription(s) **IGI LG762573664**

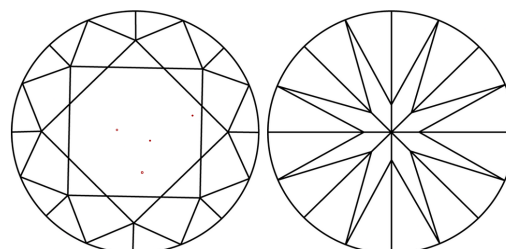
Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process. Type IIa

**PROPORTIONS**



Sample Image Used

**CLARITY CHARACTERISTICS**



**KEY TO SYMBOLS**

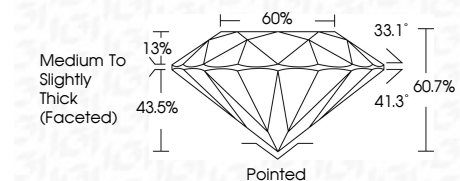
Red symbols indicate internal characteristics.  
Green symbols indicate external characteristics.

**COLOR**

D E F G H I J Faint Very Light Light

**CLARITY**

FL	IF	VS <sup>1-2</sup>	VS <sup>1-2</sup>	SI <sup>1-2</sup>	I <sup>1-3</sup>
Flawless	Internally Flawless	Very Very Slightly Included	Very Slightly Included	Slightly Included	Included



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**IGI**



January 24, 2026	1.84 CARAT	E	VS 1	IDEAL	60%	Medium To Slightly Thick (Faceted)	Pointed	EXCELLENT	EXCELLENT	NONE	IGI LG762573664
IGI Report No LG762573664	Carat Weight	Color Grade	Clarity Grade	Cut Grade	Depth	Table	Girdle	Polish	Symmetry	Fluorescence	Inscription(s)
ROUND BRILLIANT	7.90 - 7.94 X 4.81 MM										

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